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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Minoru YOSHIDA et al.

Serial No.:

10/765,920

Filed:

January 29, 2004

Title:

PATTERN DEFECT INSPECTION METHOD AND ITS

**APPARATUS** 

Group:

2878

Examiner:

ZETTL, Mary E.

Confirmation No.:

2671

## PRELIMINARY AMENDMENT FILED WITH REQUEST FOR CONTINUED EXAMINATION (RCE)

Mail Stop: AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

October 10, 2006

Sir:

In response to the Office Action dated April 10, 2006, please amend the above-identified application as listed below and as set forth on the following pages:

Amendments to the claims begin on page 2:

Remarks are included beginning on page 13; and

Authorization is included on page 19.